

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Toshiyuki Kawaguchi

Serial No.: 10/540,825

Filed: June 23, 2005

Confirmation No.: 8886

Date: December 30, 2008

Group Art Unit: 1794

Examiner: Elizabeth A. Robinson

For: ELECTROMAGNETIC NOISE SUPPRESSOR, ARTICLE WITH  
ELECTROMAGNETIC NOISE SUPPRESSING FUNCTION, AND METHOD OF  
MANUFACTURING THE SAME

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**Via EFS Web**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**APPLICANT'S STATEMENT OF THE SUBSTANCE OF THE INTERVIEW**

Sir:

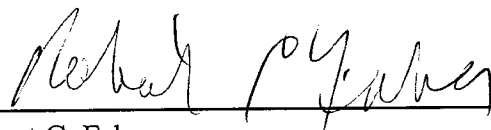
Applicant thanks the Examiner for the opportunity of a telephone interview conducted on September 26, 2008 in the above-identified application. With respect to the requirement to provide an applicant's Statement of the Substance of the Interview, applicant notes as follows.

In the course of the interview, applicant's representative, George Brieger, Registration No. 52,652, explained that as described, for example, at paragraph 356 of applicant's disclosure with reference to comparative Example 12, the acronym "MSL" stands for micro strip line, which is a method of measuring electromagnetic noise transmission (or reflection). It was agreed that an amendment to the Drawings was to be filed, and this was done as part of the Amendment filed on September 26, 2008.

THIS CORRESPONDENCE IS BEING  
SUBMITTED ELECTRONICALLY  
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PATENT AND TRADEMARK OFFICE  
EFS FILING SYSTEM  
ON **DECEMBER 30, 2008**

RCF:GB:ns

Respectfully submitted,



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